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PATENT #3/103
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Hiroyuki Yano et al.
U.S. Serial No. : 09/870,085
Filing Date : May 30, 2001
For : **MANUFACTURING METHOD OF SEMICONDUCTOR
DEVICE**
Group Art Unit : Not Known Yet

745 Fifth Avenue
New York, New York 10151

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, DC 20231, on July 26, 2001.

Grace L. Pan, Reg. No. 39,440
Name of Applicant, Assignee or Registered Representative


Signature

July 26, 2001
Date of Signature

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INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

The Examiner's attention is respectfully invited to review the following enclosed and listed documents which are also listed on the accompanying Form PTO-1449, enclosed in duplicate.

UNITED STATES PATENTS

1. U.S. Patent No. 5,426,073, Issued: June 20, 1995 to Imaoka et al., and
2. U.S. Patent No. 6,016,265, Issued: January 18, 2000 to Yoshida et al.

FOREIGN PATENTS

1. Japanese Patent No. 2-100319, Published: April 12, 1990 to Imaoka et al.

Pursuant to Rule 37 C.F.R. §1.97(b)(3), an Information Disclosure Statement shall be considered by the Patent Office filed before the mailing date of a first Office Action on the merits.

This Information Disclosure Statement is not a representation that the documents cited herein are considered most pertinent, or that a search has been undertaken, or that any of the cited documents are indeed prior art. The Examiner is invited to undertake an independent search. Applicants assert that the claimed invention is patentable over these documents.

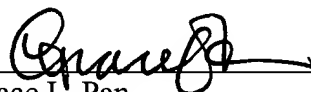
Applicants respectfully request that the Examiner consider and make of record the documents cited herein and that a copy of Form PTO-1449, appropriately initialed by the Examiner, be returned to Applicants' attorney.

It is believed no fee is due, however, the Examiner is authorized to charge any deficit or credit any overpayment to Deposit Account No. 50-0320.

Respectfully submitted,

FROMMER LAWRENCE & HAUG LLP
Attorneys for Applicants

By:



Grace L. Pan
Registration No. 39,440
Tel. (212) 588-0800
Fax (212) 588-0500